SATHI FOUNDATION IIT KHARAGPUR

CIN:U73100WB2021NPL244937Registered Office:IIT Kharagpur Campus, Paschim Medinipur, Kharagpur, West Bengal, India, 721302Website:http://www.sathi.iitkgp.ac.in/Email:sathiops@iitkgp.ac.inTelephone: +91-3222-214792/91

ToF-SIMS Sample Details Form

Date:

1. User Profile:

Name	
Designation	
Department / Organization	
Address with Pin code	
GST No. & PAN No. (if applicable)	
Roll Number (for students)	
Mobile number & Email	

2. Sample Details:

Nature	Ceramic/ Metal & alloys / Polymers / Semiconductor / Composite / Thin film and coatings / Other	Analysis mode: (Tick all	Spectrum / Depth Profiling* (Max 200nm)/ Map (Mosaic area mapping)
Туре	Solid / Powder / Other (Please specify)	the	
Composition		 required options) 	*Depth required: nm
No. of samples		Duration	3 hours/ 6 hours
No. of sumples		Physical	
Treatment	Heating / Cooling	Presence	Yes / No
required	Temp required (°C):	during	
		Analysis	

3. Declaration:

I hereby agree to acknowledge the use of SATHI Foundation IIT Kharagpur facility in my related publication / patent

User Signature with date

Supervisor Signature with seal (for student)	
Supervisor name:	Email:
Mobile number:	

4. Instructions for users:

- a. Sample should be submitted in the ToF-SIMS lab a day before during 9:30 am to 10 am or 4.30 pm to 5 pm.
- b. Do not call the operator during 9 to 12 noon and 2 pm to 5 pm (Analysis time)
- c. Bring a new Pen drive / DVD (4.37GB) formatted as "Flash Drive" for data copying.

Approved: Yes / No Slot Date & time: Facility In charge: Completion date:....